



*Handwritten signature and number 1763*

PATENT

Attorney Docket :  
033082M123

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO. 2600

In re the application of:

Masayuki TOMOYASU

Serial No. : 10/049,989

Filed : February 20, 2002

Art Unit : 1763

Examiner : Anna M. CROWELL

For : Plasma Processing System, and Plasma Processing Method

AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

A response to the Office Action dated August 11, 2004 was due by November 11, 2004. A Petition for Extension of Time (three months, large entity) is also enclosed, extending the due date to February 11, 2005. Therefore, please accept this Amendment as timely filed.

In response to the Office Action dated August 11, 2004, kindly amend the above-identified patent application as set forth below.